

862.C2238

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
Shigeyuki UZAWA	:	Examiner: Unassigned
Appln. No.: 09 865,454)	
Filed: May 29, 2001	:	Group Art Unit: 2881
For: EXPOSURE APPARATUS, DEVICE)	
MANUFACTURING METHOD,	:	October 10, 2001
SEMICONDUCTOR)	
MANUFACTURING PLANT AND	:	
METHOD OF MAINTAINING)	
EXPOSURE APPARATUS	:	

Commissioner for Patents
Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Copies of the listed documents are also enclosed.

FEE STATEMENT


No fee or statement is required in connection with this Information Disclosure statement, since it is being submitted prior to the last of (1) issuance of a first official action on the merits or (2) expiration of the three month period following filing of the above-captioned application.

REMARKS

It is respectfully requested that the cited information be considered by the Examiner and that an annotated copy of the enclosed Form PTO-1449 be returned with the next official communication indicating that such information has been considered.

Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



Attorney for Applicant
Steven E. Warner
Registration No. 33,326

FITZPATRICK, CELLA, HARPER & SCINTO
30 Rockefeller Plaza
New York, New York 10112-3801
Facsimile: (212) 218-2200

SEW:lmj